


Substitute for Form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>			<i>Complete if Known</i>		
			Application Number	09/197,534	
			Filing Date	November 23, 1998	
			First Named Inventor	Shunpei YAMAZAKI et al.	
			Art Unit	2823	
			Examiner Name	William D. Coleman	
Sheet	1	of	1	Attorney Docket Number	740756-1894


U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patent or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-4,906,491	03/06/1990	Yamazaki	
		US-			
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FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patent or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ³
		Country Code ⁴ Number ⁴	Kind Code ² (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ³
		Chinese Office Action dated 07/09/2004 issued in Chinese Patent Application No. 01104515.9 filed: 06/26/1993 "A Method of Manufacturing a Semiconductor Device"	

Examiner Signature		Date Considered	SEPT 20, 2004
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¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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		Number - Kind Code ² (if known)			
		US-4,497,015		01/29/1985	Konno et al.
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		Country Code ³	Number ⁴ Kind Code ⁵ (if known)			
		JP	2-255292	10/16/1990		AB
		JP	1-239837	09/25/1989		AB
		JP	58-191420	11/08/1983		AB
		JP	58-127318	07/29/1983		AB
		JP	1-283917	11/15/1989	HASEGAWA	AB

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
		"Improving the Uniformity of Poly-Si Films Using a New Excimer Laser Annealing Method for Giant-Microelectronics", Hiroyuki Kuriyama et al., Jpn. J. Appl. Phys. Vol. 31, Part 1, No. 128, December 1992, pp. 4550-4554.	
		"p.-28: 3.7-8n.-Diagonal STN-LCD with Stripe Electrode Patterns Fabricated by an Excimer-Laser Scribing System" T. Konuma et al., Semiconductor Energy Laboratory Co., Ltd., 550-553 SID 93 Digest.	

Examiner Signature	<i>William D. Coleman</i>	Date Considered	Sept. 20, 2004
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